

#21/C 500.3809EXODIVED

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

FICE JAN 30 2003 TECHNOLOGY COURS

Applicants:

Takayoshi WATANABE, et al.

Application No.:

09/462,796

Filing Date:

January 13, 2000

Title:

SEMICONDUCTOR DEVICE, MOUNTING STRUCTURE

THEREOF AND METHOD OF FABRICATION THEREOF

Art Unit:

2811

Examiner:

Nitin Parekh

AMENDMENT

Assistant Commissioner for Patents Washington, D.C. 20231

January 27, 2003

Sir:

In response to the Office Action dated September 26, 2002, please amend the application as follows:

IN THE CLAIMS

Please cancel claims 1-33 without prejudice or disclaimer and add new claims 34-53 as follows:

34. A method of producing a semiconductor device comprising the steps of: forming a plurality of pyramidal bump electrodes of the semiconductor device; and